

## **T–I Max CEM**Next–Generation CEM Analyzer

GASES & CHEMICALS

CEMS

**ENEDGV** 

SEMI & HB LED

ATMOSPHERIC

LAB & LIFE SCIENCE

## Designed for Continuous Emissions Monitoring (CEM), the robust and compact T-I Max CEM offers:

- Accuracy traceable to the world's major national reference labs
- High specificity—no interference
- Sub-ppb detection capability
- No periodic sensor replacement/maintenance
- Unprecedented speed of response
- Wide dynamic range

Delivering your best measurements, the extremely versatile T-I Max CEM is used for monitoring gas concentrations of target compounds, both for compliance and process control. The T-I Max CEM analyzer represents the latest advancement in Continuous-Wave Cavity Ring-Down Spectroscopy designed for superior performance and unprecedented speed of response. It is an ideal, proven solution for MATS HCl compliance needs. As such, applications include continuous emissions monitoring of sources, such as cement kilns, power plants, paper mills, and refineries. Using Tiger Optics' T-I Max CEM analyzer, you can verify concentrations of target compounds with parts-

per-billion accuracy, drift-free stability, and virtually immediate response.

The T-I Max CEM detects NH<sub>3</sub>, HCl, HF, H<sub>2</sub>S, and CH<sub>4</sub>, among other species. You will find our analyzer is easy to install, exceptionally intuitive to use, and effortless to maintain. The modern software enables you to easily configure the analyzer via its touchscreen display and to communicate with virtually any manufacturer's DAHS. Two units fits into one 19" rack mount. The robust design—free of moving parts—results in an analyzer that has a high mean time between failures (MTBF) and a very low cost of ownership (COO).



## T-I Max CEM

## Next-Generation CEM Analyzer



Performance			
Operating range	See table below		
Detection limit (LDL, 3σ/24h)	See table below		
Precision (1σ, greater of)	± 0.75% or 1/3 of LDL		
Accuracy (greater of)	± 4% or LDL		
Speed of response	See table below		
Environmental conditions	10°C to 40°C		
	30% to 80% RH (non-condensing)		
Storage temperature	-10°C to 50°C		

Gas Handling System and Conditions*				
Wetted materials	316L stainless steel			
	10 Ra surface finish			
Gas connections	1/4" male VCR inlet and outlet			
	(1/4" Swagelok® adapters included)			
Inlet pressure	0 – 10 psig			
Outlet pressure	Vacuum (<10 Torr)			
Flow rate	~2 slpm max.			
Sample gases	Air, diluted stack gas			
Gas temperature	Up to 60°C			

Dimensions	H x W x D [in (mm)]
Standard sensor	8.73 x 8.57 x 23.6 (222 x 218 x 599)
Sensor rack	8.73 x 19.0 x 23.6 (222 x 483 x 599)
(fits up to two sensors)	
Weight	
Standard sensor	33 lbs (15 kg)
Electrical and Interfaces	
Platform	Max series analyzer
Alarm indicators	2 user programmable
	1 system fault
	Form C relays
Pour requirements	90 - 2/10 VAC 50/60 Hz

			· · · · · · · · · · · · · · · · · · ·
Gas connections	1/4" male VCR inlet and outlet	Power requirements	90 – 240 VAC, 50/60 Hz
	(1/4" Swagelok® adapters included)	Power consumption	40 Watts max.
Inlet pressure	0 – 10 psig	Signal output	Isolated 4–20 mA
Outlet pressure	Vacuum (<10 Torr)	User interfaces	5.7" LCD touchscreen
Flow rate	~2 slpm max.		10/100 Base-T Ethernet
Sample gases	Air, diluted stack gas		USB, RS-232, RS-485
Gas temperature	Up to 60°C		Modbus TCP (optional)
		Data storage	Internal or external flash drive
		Certification	CE Mark

Performance:	Range <sup>†</sup>	LDL (3σ)	Precision (1σ) @ zero	Speed of Response
T-I Max CEM NH <sub>3</sub>	0 – 40 ppm	6 ppb	2 ppb	1 min to 95%
T-I Max CEM HCI	0 – 4 ppm	0.75 ppb	0.25 ppb	30 sec to 90%
T-I Max CEM HF	0 – 1 ppm	0.15 ppb	0.05 ppb	30 sec to 90%
T-I Max CEM H <sub>2</sub> S	0 – 500 ppm	40 ppb	13 ppb	30 sec to 95%
T-I Max CEM CH <sub>4</sub>	0 – 20 ppm	1.5 ppb	0.5 ppb	30 sec to 95%

<sup>\*</sup>Vacuum source with >2 slpm @ 10 Torr required †Higher ranges are available, please contact us. U.S. Patent # 7,277,177



275 Gibraltar Road, Horsham, PA 19044 Phone: +1 (215) 656 4000 · Fax: +1 (215) 343 7168  $sales@tigeroptics.com \cdot www.tigeroptics.com$ 



